

Notice of References Cited	Application/Control No. 09/970,939		Applicant(s)/Patent Under Reexamination ANDO, YASUHISA	
	Examiner Tamai IE Karl		Art Unit 2834	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,545,385	04-2003	Miller et al.	310/309
	B	US-5,862,003	01-1999	Saif et al.	359/871
	C	US-			
	D	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	05-116757	05-1993	Japan	Ozaki et al.	B65G054/02
	O	2002-119072	04-2002	Japan	Ando	H02N001/00
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NON-PATENT DOCUMENTS

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	U	Fan et al., "Self Assembled Microactuated XYZ Stages for Optical Scanning and Alignment;", 6/1997, International Conference on Solid State Sensors and Actuators, pages 319-322.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.